



PATENT  
Atty. Dkt. No. AMAT/6826P1/DSM/BCVD/JR

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

In re Application of:  
Kim, et al

Serial No.: 10/732,904

**Filed:** December 10, 2003

**Confirmation No.: Unassigned**

For: Nitrogen-Free Dielectric Anti-Reflective Coating and Hardmask

Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Dear Sir:

<b>CERTIFICATE OF MAILING</b> <b>37 CFR 1.8</b>	
<p>I hereby certify that this correspondence is being deposited on  <u>4/18</u>, 2004, with the United States Postal Service as First Class Mail in an envelope addressed to:  Commissioner for Patents, P.O. Box 1450 Alexandria, VA  22313-1450.</p>	
<u>4/8/04</u> Date	<u>Kris R. Hale</u> Signature

## **CLAIM TO PRIORITY**

Applicants reaffirm the claim for priority of the following patent applications referred to in Applicant's Specification:

The application is a continuation in part of United States Application Serial Number 10/193,489 filed July 11, 2002, and claims priority to United States Application Serial Number 60/433,445 filed December 13, 2002, and United States Application Serial Number 60/526,259 filed December 1, 2003.

Respectfully submitted,

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